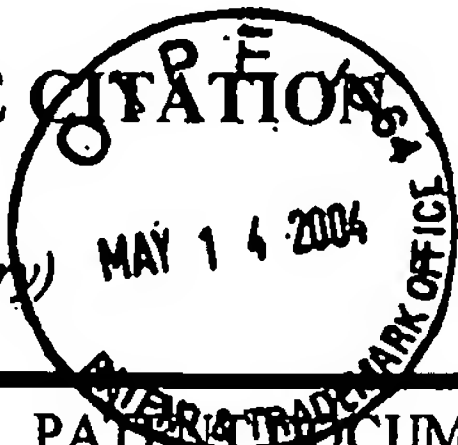


Form PTO-1449				Attorney Docket No. 220101-1011		Serial No. 10/772,740	
INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Applicant Yonhua Tzeng			
				Filing Date February 5, 2004		Group 1762	



U.S. PATENT DOCUMENTS							
Examiner Initials	Item	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
EF	A	6,284,315	9/4/01	Tzeng	427	249.1	1/14/00

FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No

OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, etc.)</i>		
EF	B	Tzeng, et al.; Effects of oxygen and hydrogen on electron field emission from microwave plasma chemically vapor deposited microcrystalline diamond, nanocrystalline diamond, and glassy carbon coatings

* EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

EXAMINER'S SIGNATURE: <div style="text-align: center;">/Eric Fuller/</div>	DATE CONSIDERED: <div style="text-align: center;">06/25/2006</div>
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